L Number	Hits	Search Text	DB	Time stamp
1	40155	356/$.ccls.	USPAT	2003/04/10 08:07
2	85	356/$.ccls. and (wafer or substrate or disk) adj3 tilt	USPAT	2003/04/10 08:16
3	2	(356/$.ccls. and (wafer or substrate or disk) adj3 tilt) and comparator	USPAT	2003/04/10 08:17
4	1028	(wafer or substrate or disk) adj3 tilt	USPAT	2003/04/10 08:33
5	43	((wafer or substrate or disk) adj3 tilt) and comparator	USPAT	2003/04/10 08:33
6	41	(((wafer or substrate or disk) adj3 tilt) and comparator) not (356/$.ccls. and (wafer or substrate or disk) adj3 tilt)	USPAT	2003/04/10 08:17
7	249	wafer adj3 tilt	USPAT	2003/04/10 08:35
8	5	(wafer adj3 tilt) and comparator	USPAT	2003/04/10 08:35
9	485	wafer adj3 tilt$3	USPAT	2003/04/10 08:35
10	10	(wafer adj3 tilt$3) and comparator	USPAT	2003/04/10 08:47
11	60	356/$.ccls. and tilt adj3 mechanism	USPAT	2003/04/10 08:47
12	102	356/$.ccls. and tilt$3 adj4 compensat$5	USPAT	2003/04/10 08:47
13	9	(356/$.ccls. and tilt$3 adj4 compensat$5) and comparator	USPAT	2003/04/10 08:50
14	196	356/$.ccls. and wafer adj3 positioning	USPAT	2003/04/10 08:50
15	16	(356/$.ccls. and wafer adj3 positioning) and comparator	USPAT	2003/04/10 08:55
16	2	((356/$.ccls. and wafer adj3 positioning) and comparator) and tilt	USPAT	2003/04/10 08:54
17	322	356/$.ccls. and measur$5 adj4 tilt$3	USPAT	2003/04/10 08:58
18	29	(356/$.ccls. and measur$5 adj4 tilt$3) and comparator	USPAT	2003/04/10 09:24
19	74	(356/$.ccls. and measur$5 adj4 tilt$3) and wafer	USPAT	2003/04/10 09:25
20	55	(356/$.ccls. and measur$5 adj4 tilt$3) and comparat$5	USPAT	2003/04/10 09:25
21	6	((356/$.ccls. and measur$5 adj4 tilt$3) and comparat$5) and wafer	USPAT	2003/04/10 09:25